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## Application No. Applicant(s) 10/735,913 KIM, JAE-HONG Notice of Allowability Examiner **Art Unit** Craig A. Thompson 2813 -- The MAILING DATE of this communication appears on the cover sheet with the correspondence address--All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. 1. This communication is responsive to 12/16/2003. 2. The allowed claim(s) is/are 1-20. 3. The drawings filed on 12/16/2003 are accepted by the Examiner. 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) 🔯 All b) Some\* c) None of the: 1. \( \subseteq \text{ Certified copies of the priority documents have been received.} \) 2. Certified copies of the priority documents have been received in Application No. 3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). \* Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient. 6. CORRECTED DRAWINGS (as "replacement sheets") must be submitted.

(a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached

(b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of

each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).

Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of

7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.

Attachment(s)
1. 🔀 Notice of References Cited (PTO-892)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)
<ol> <li>Information Disclosure Statements (PTO-1449 or PTO/SB/08) Paper No./Mail Date 12/16/03</li> </ol>
4. ☐ Examiner's Comment Regarding Requirement for Deposit
of Biological Material

1) hereto or 2) to Paper No./Mail Date

Paper No./Mail Date

5. Notice of Informal Patent Application (PTO-152)
6. Interview Summary (PTO-413), Paper No./Mail Date
7. Examiner's Amendment/Comment
8.   Examiner's Statement of Reasons for Allowance
9.  Other

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## **REASONS FOR ALLOWANCE**

The following is an examiner's statement of reasons for allowance: prior art of record does not describe or suggest applicant's invention set forth in claims 1-11, a method for manufacturing a shallow trench isolation wherein a trench is formed in a semiconductor substrate, a hydrogen based high density plasma oxide layer is formed, and nitrogen based high density plasma a oxide layer is formed, and a helium based high density plasma oxide are formed in conjunction with the step a carrying out a two stage thermal process for removing fluorine in the NF<sub>3</sub>-based oxide layer, in the context of the recited processes. Similarly prior art of record does not describe or suggest the invention of claims 12-22 wherein the thermal process for removing fluorine is the last recited process step of the independent claim, and in the context of the recited processes.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## Cited Prior Art

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. Kim et al. (U.S. Patent No. 6,660,613) teaches using a high density plasma (HDP) in shallow trench isolation, but teaches adding (not extracting) fluorine for removing dangling bonds (see column 3 line 42 to column 4, line 44). Kim et

al. (U.S. Patent 6,849,520) teaches forming a shallow trench isolation (title) and forming an oxide layer with fluorine as well as exposure to a fluorine atmosphere (column 2, lines 35-68). Kim et al. (US Patent Publication No. US 2004/0082143 A1) teaches a method for forming an STI type isolation (title) including exposure to fluorine (see 0014-0016). Kim et al. (US Patent Publication US 2003/0045070 A1) teaches forming an STI type isolation including exposure to fluorine (see 0026). However, none of these references, in conjunction with the prior art, teach or suggest the formation of a H<sub>2</sub>-HDP oxide, a NF<sub>3</sub>-based HDP oxide and a He-HDP oxide in conjunction with the two-stage thermal process for removing fluorine of the instant invention.

## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Craig A. Thompson whose telephone number is (571)272-1699. The examiner can normally be reached on Monday-Friday 8:00 am - 4:30 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead, Jr. can be reached on (571)272-1702. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for

published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only.

For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

you have questions on access to the Private PAIR system, contact the Electronic

Business Center (EBC) at 866-217-9197 (toll-free).

Craig A. Thompson Primary Examiner

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25 June 2005